

**Search Notes**

Application/Control No.

10/658,700

Examiner

Pritham Prabhakher

Applicant(s)/Patent under  
Reexamination

KASUGA ET AL.

Art Unit

2622

**SEARCHED**

Class	Subclass	Date	Examiner
348	308	11/13/2006	PP
348	230.1	11/13/2006	PP
348	294	11/13/2006	PP
348	296	11/13/2006	PP

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
On East [US-PGPUB, USPA, USOCR, EPO, JPO, DERWENT, IBM_TDB] SEE SEARCH TERMS ATTACHED]	12/14/2006	PP
Inventor Name Search	12/14/2006	PP
Google Search Terms: [silicidation, ion implanting, cmos and nmos differences]	12/15/2006	PP